

Search Notes

Application/Control No.

10/803,587

Examiner

Tan V. Mai

Applicant(s)/Patent under
Reexamination

UMENO, KEN

Art Unit

2193

SEARCHED

| Class | Subclass | Date | Examiner |
|---------|----------|------------|----------|
| updated | search | 11/12/2007 | MAI |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |
| | | | |

INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
| | | | |
| | | | |
| | | | |
| | | | |

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|--|------------|------|
| updated search (see search history printout(s)) | 11/12/2007 | MAI |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |
| | | |